

# Density Dependence of the Excitation Gap in Si/SiGe Bilayers

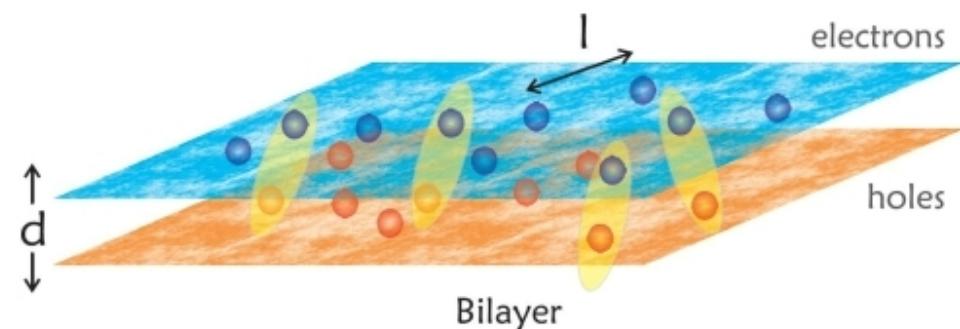
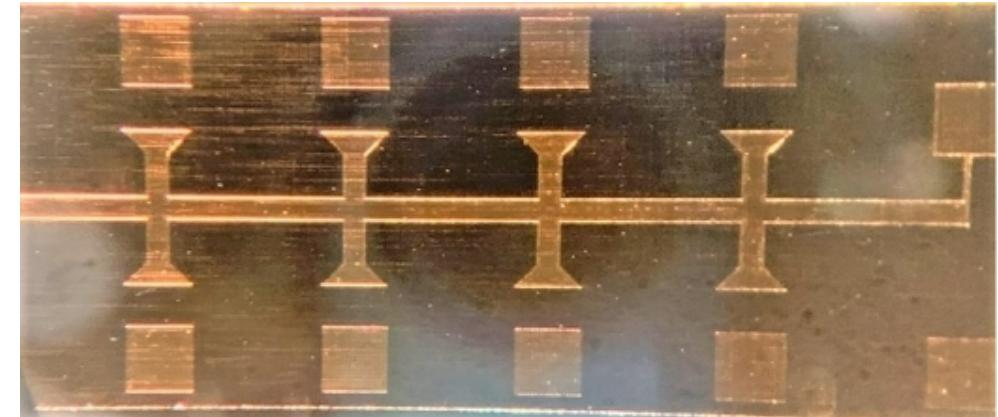
Session: Integer Quantum Hall Effect: Transport Phenomena

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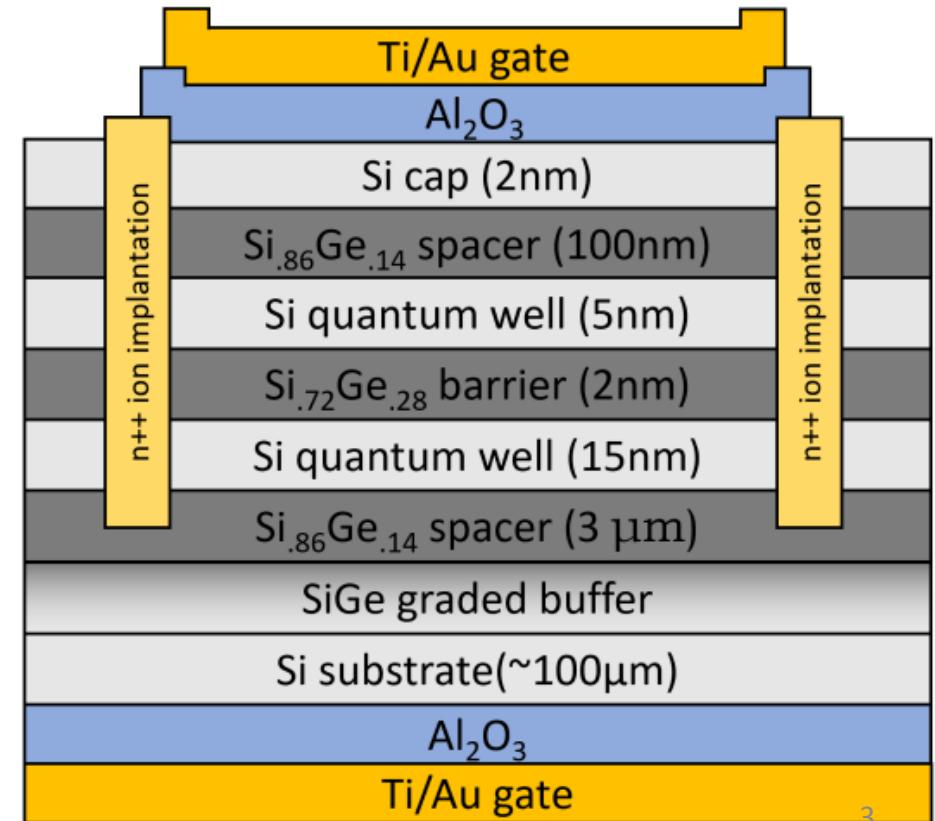
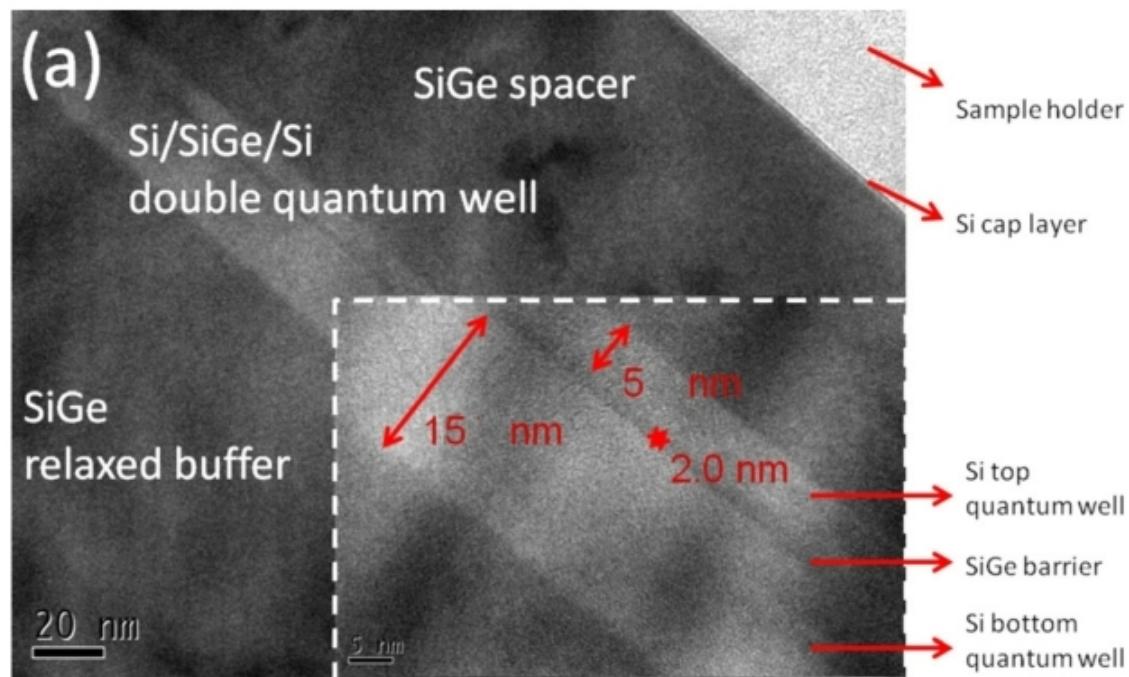
# Motivation

- Si-based heterostructures – CMOS technology
- SiGe-based heterostructures
  - Undoped structure with high  $\mu$ /low disorder
  - $^{28}\text{Si}$  (nuclear spin free) – decoherence
    - Quantum computing
  - Exciton Condensation
    - Resistanceless Transistors
  - Valley Splitting (VS)
    - Valleytronics & Si qubit



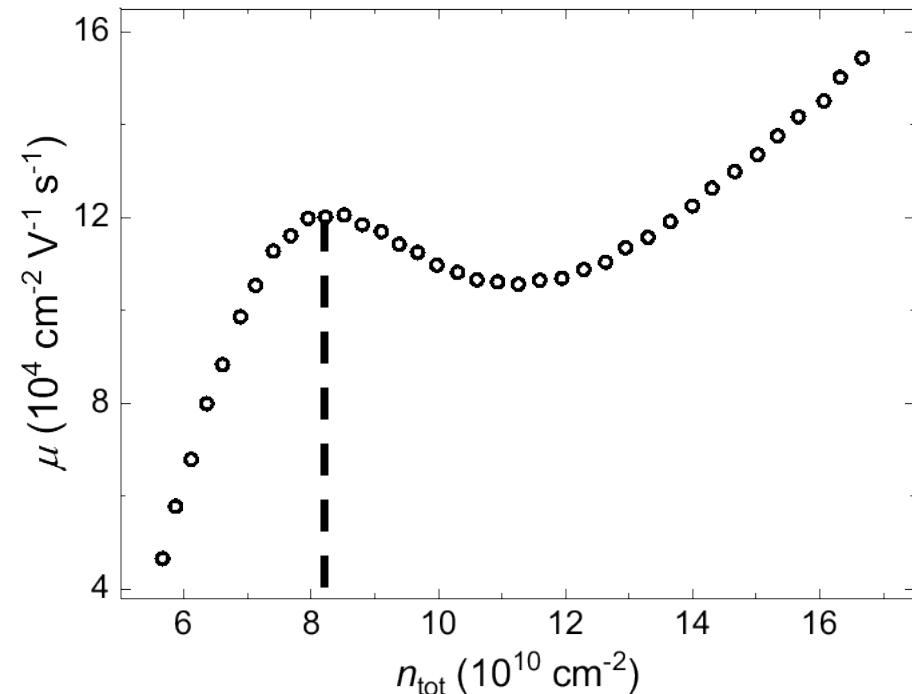
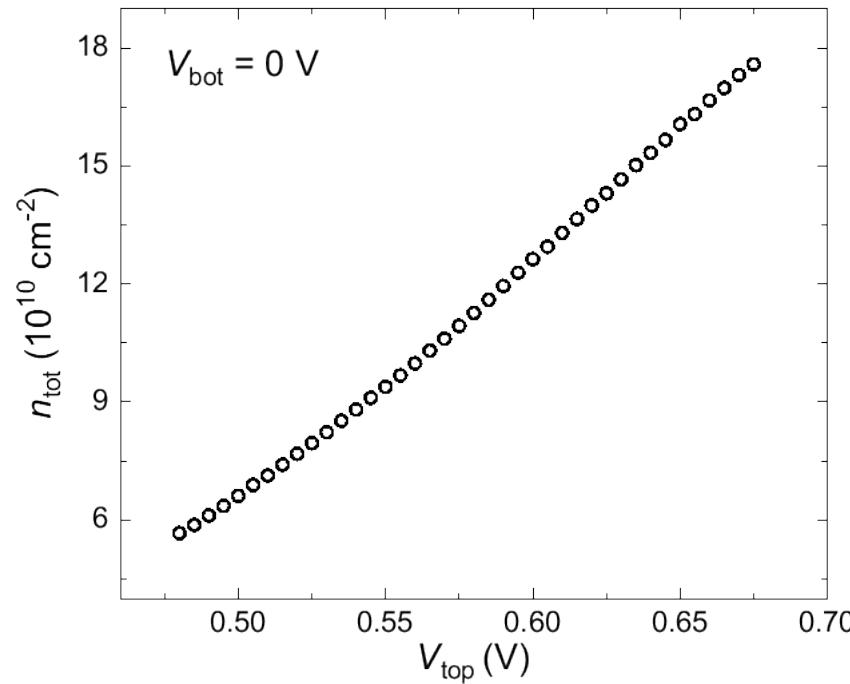
# Growth & Fabrication

- Undoped & Assymetric Double Quantum Well
- HFET w/ Hall bar geometry patterned using standard fabrication processes
- Front and BACK gate capabilities
- Hall densities from  $6.8 \times 10^{10} \text{ cm}^{-2}$  to  $3.42 \times 10^{11} \text{ cm}^{-2}$
- Hall mobility corresponding to  $3.08 \times 10^5 \text{ cm}^2/(\text{V} \cdot \text{s})$



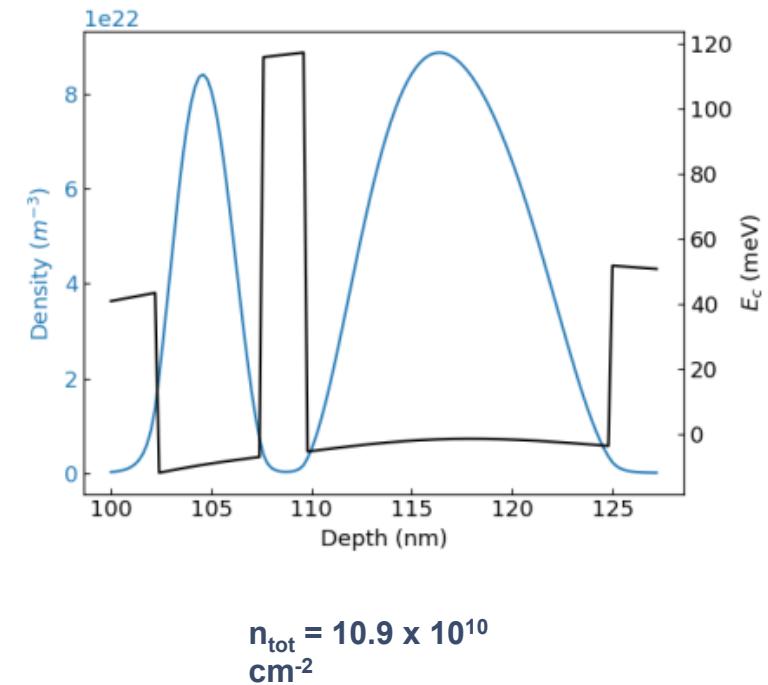
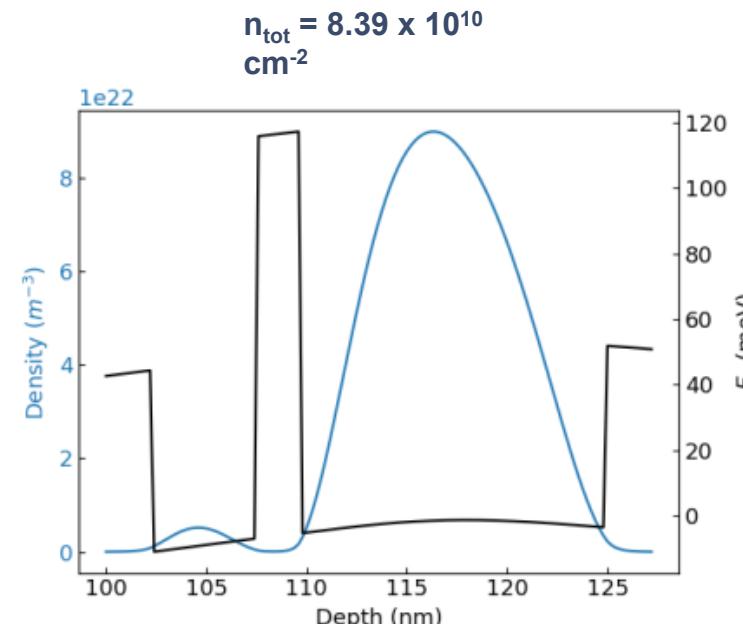
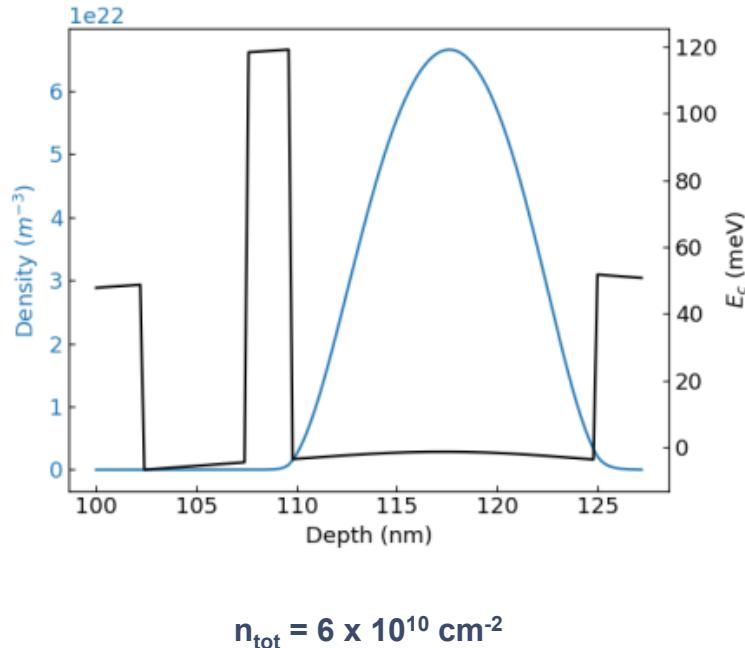
# Bilayer Behavior

- The mobility increases with Hall density until the crossover density,  $8.22 \times 10^{10} \text{ cm}^{-2}$ . ( $V_{\text{top}} = 0.53 \text{ V}$ )
- The mobility then drops to a minimum of  $1.06 \times 10^5 \text{ cm}^2/(\text{V} \cdot \text{s})$  due to inter-layer scattering and indicates the bilayer system was formed.



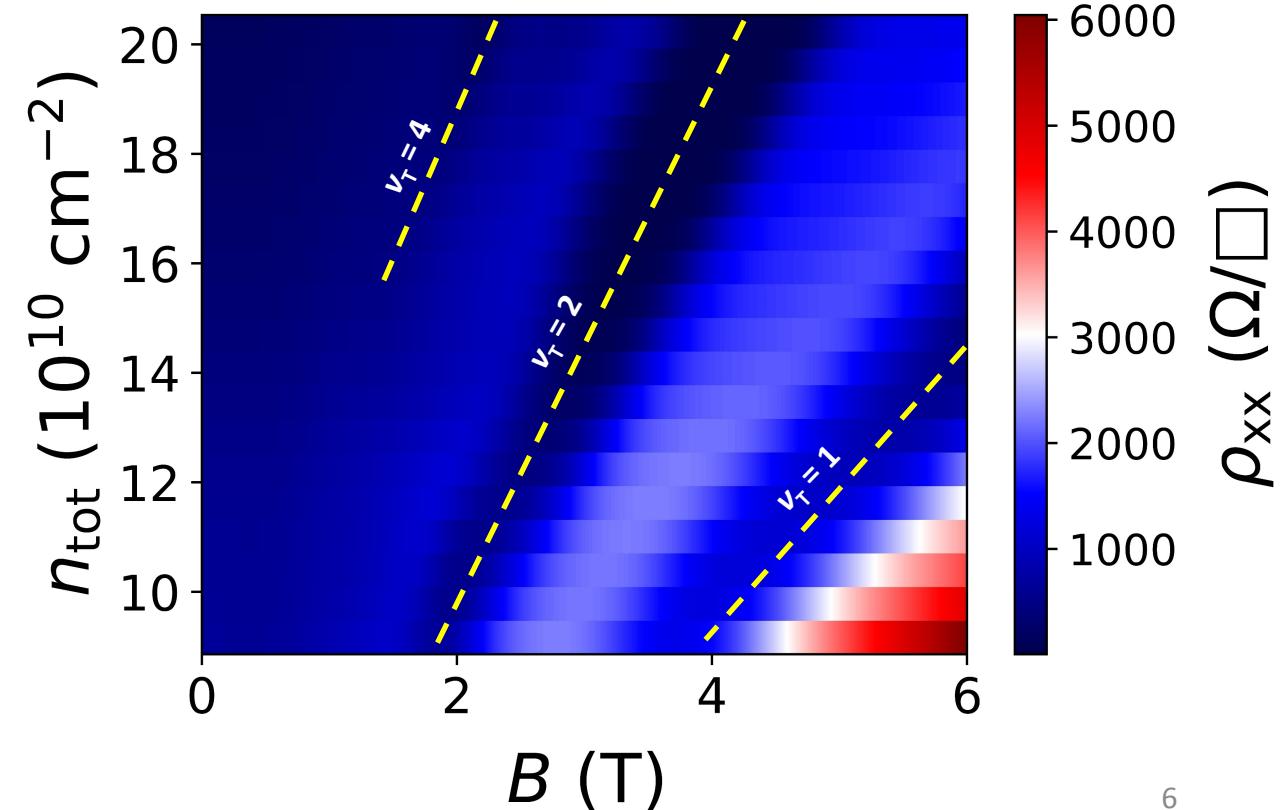
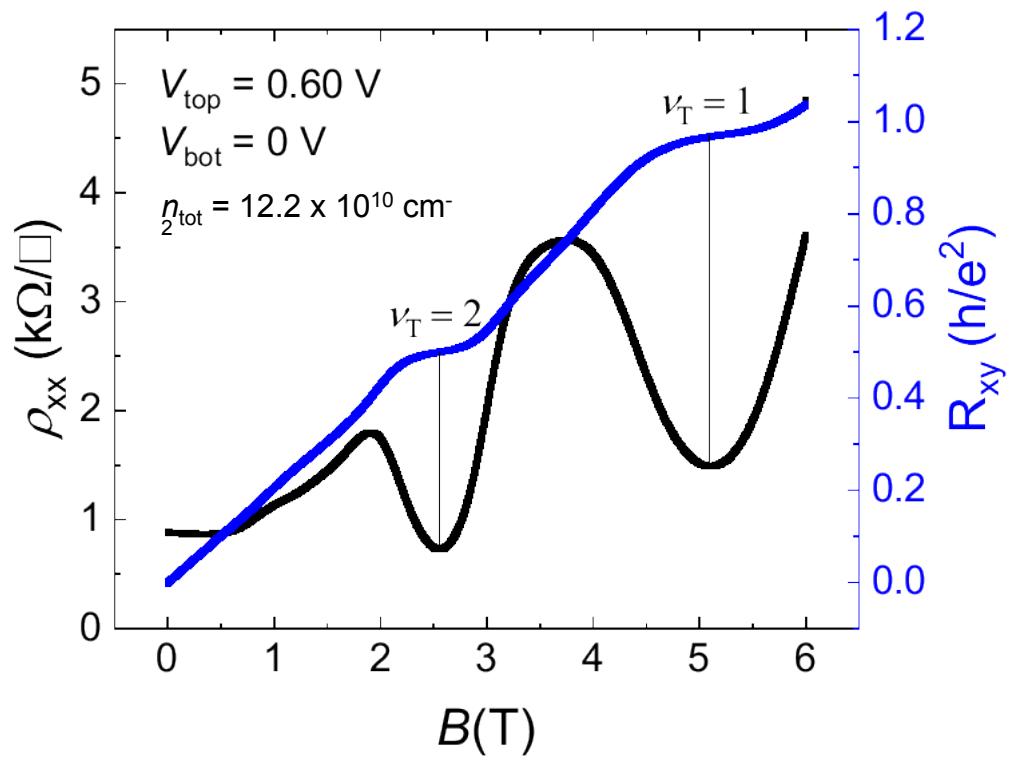
# Schrödinger-Poisson Simulations

- An iterative, self-consistent SP simulation reproduces  $n_{\text{crossover}}$  at  $8.22 \times 10^{10} \text{ cm}^{-2}$ 
  - Band gaps were artificially increased at the heterostructure's spacers
  - Nominal growth parameters
  - $\Delta_{\text{S,AS}} = E_{\text{AS}} - E_{\text{S}}$  (Single Electron Tunnel Splitting)



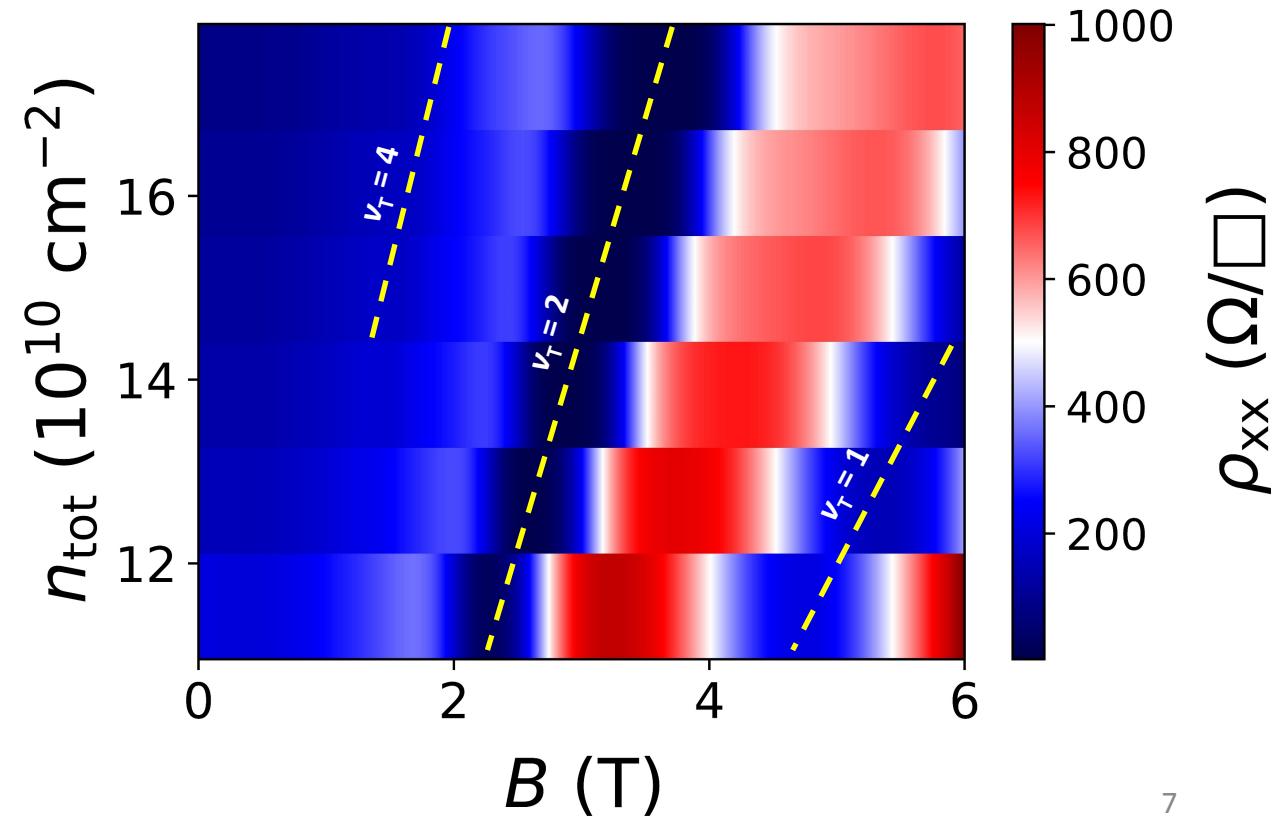
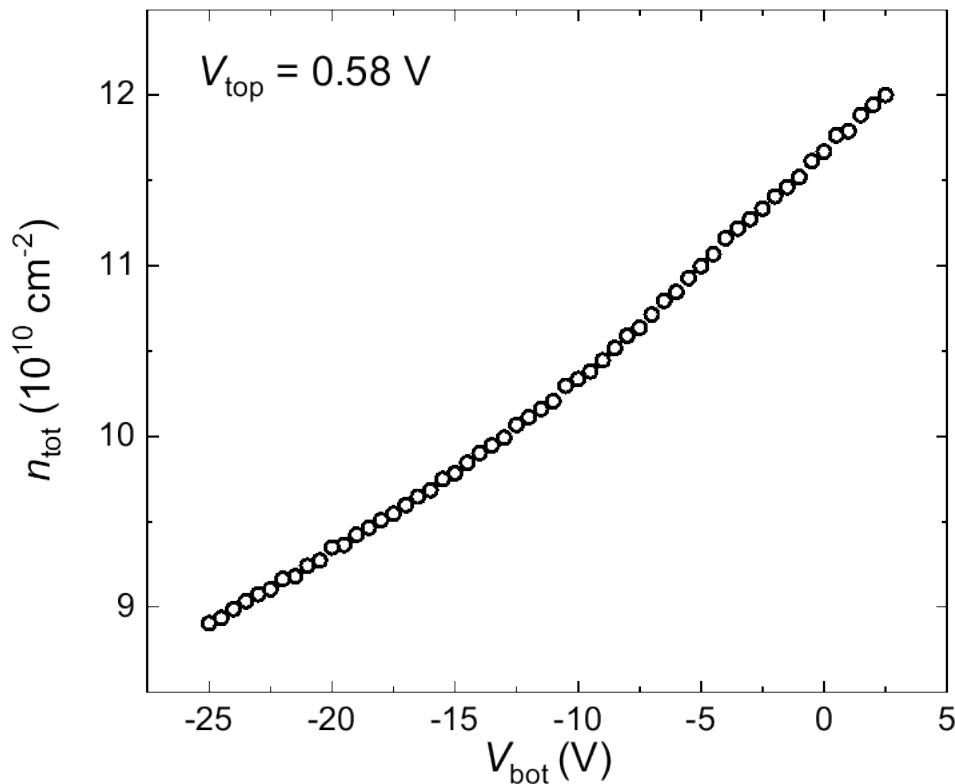
# Front Gate – Variable Imbalanced Densities

- $v_T = 1, 2, 4$   $\rho_{xx}$  minima evolves with  $n_{tot}$  and  $B$
- $R_H = \rho_{xy} = R_K/v = h/e^2v$



# Back Gate - Matched Densities

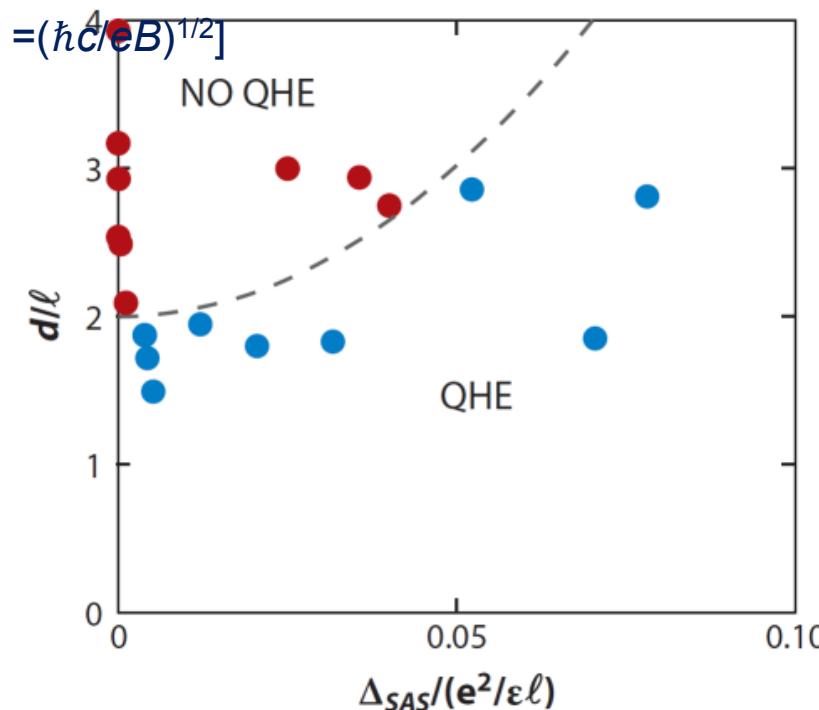
- Tuned back gate to achieve matched density
- Smaller range of available total densities possible
- $v_T = 1, 2, 4$   $\rho_{xx}$  minima evolves with  $n_{\text{tot}}$  and  $B$



# Interlayer Effects

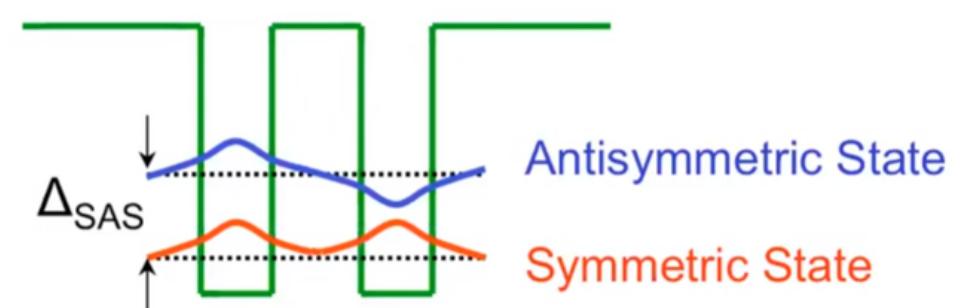
## Spontaneous Interlayer Coherence

- Easy-plane ferromagnet or a Bose-Einstein condensate of excitons
- Quantum phase transition to a compressible state above some critical layer spacing,  $d_c/\ell_b$ . [ $\ell_b$  =  $(\hbar c/eB)^{1/2}$ ]



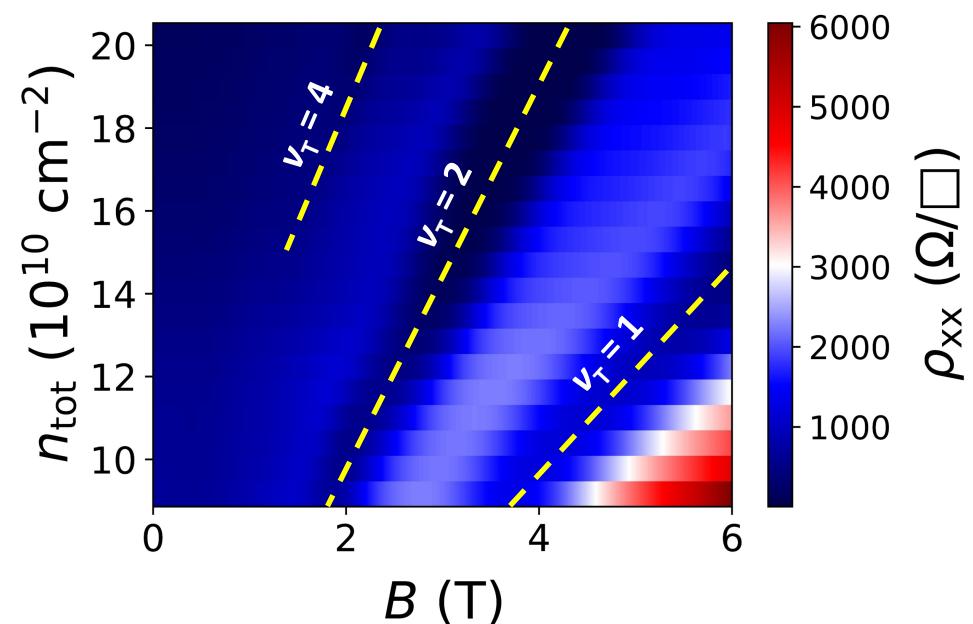
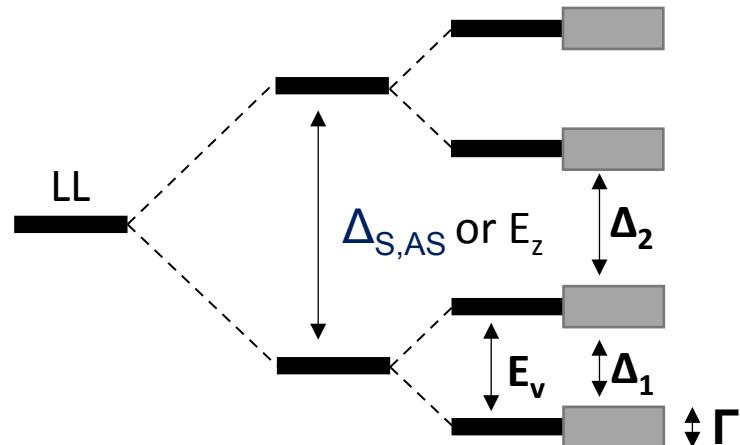
## Single Particle Tunneling Gap

- When tunneling is sufficiently strong,  $\Delta_{SAS} = \Delta_{AS} - \Delta_S$
- $\Delta_{SAS}$  decreases with increased barrier height and width



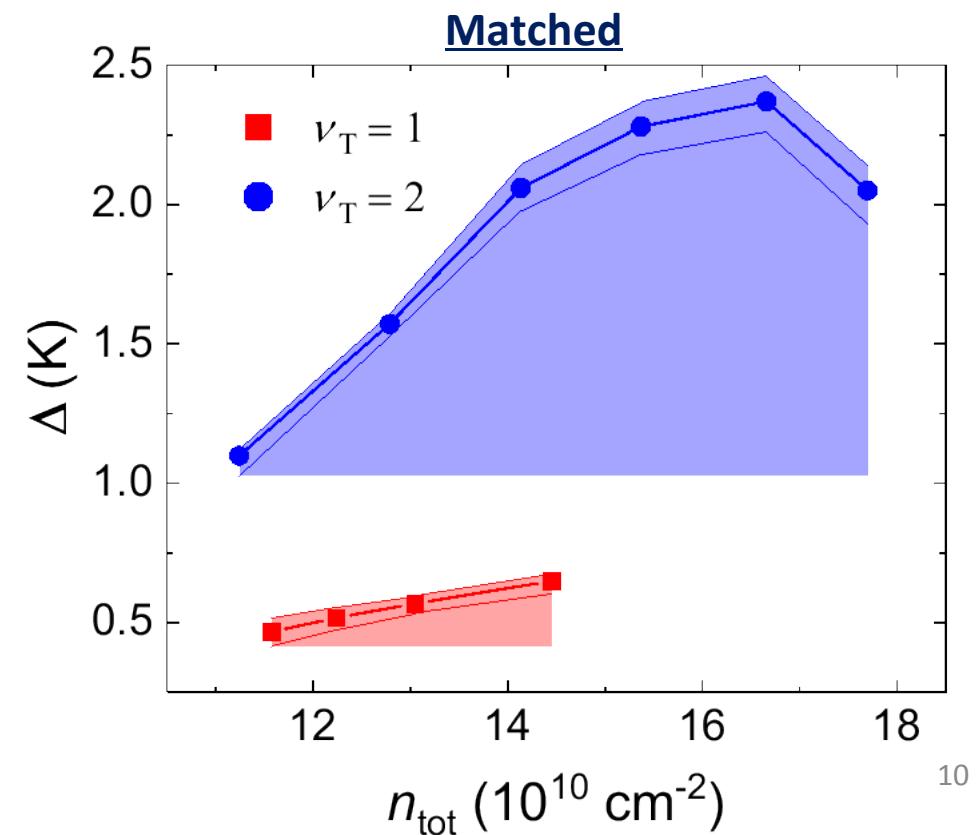
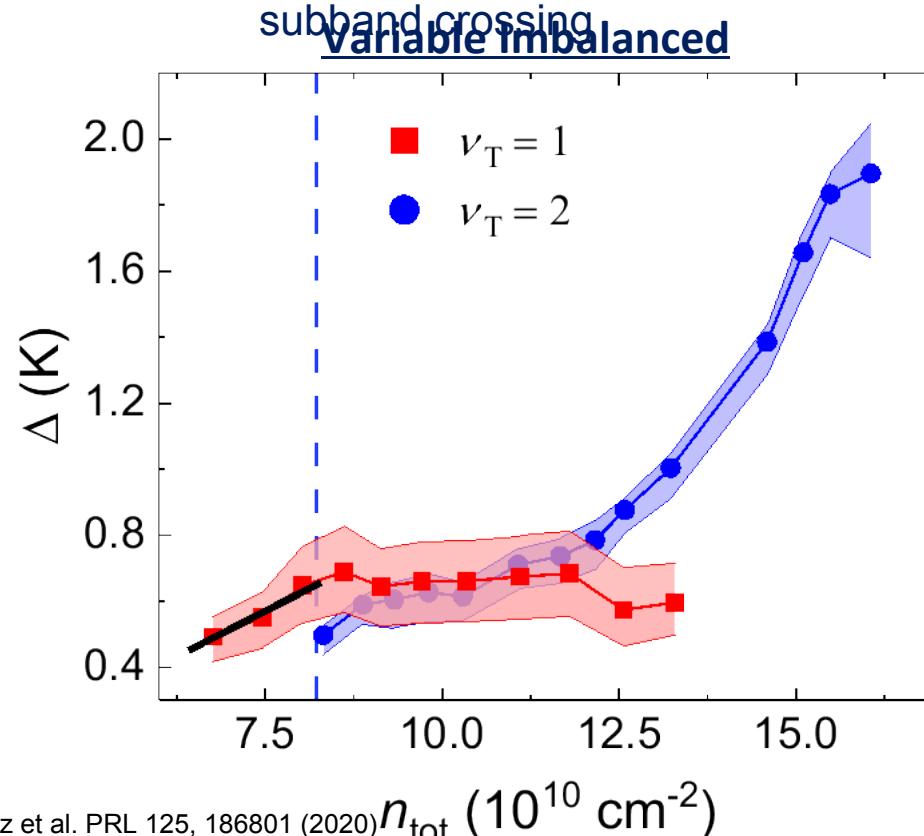
# Degeneracies

- **Single layer regime:** spins ( $\uparrow\downarrow$ ) and valleys ( $+/ -$ )
  - Valley splitting and spin is linear with  $n_{\text{tot}}(B)$
  - @ 4.13 T,  $E_v \approx 1.35$  K  $< E_z \approx 2.79$  K  $\rightarrow v_T = 1$  ( $v_T = 2$ ) attributed to valley (spin)
- **Bilayer regime:** layer (S/AS) degree of freedom
  - Single particle tunneling gap,  $\Delta_{\text{S/AS}}$ , can be estimated from SP
  - No LL crossing when transitioning into the bilayer state
    - $v_T = 1$  is attributed to valley
    - $v_T = 2$  is attributed to interlayer effects



# Extracted Activation Gaps

- The activation gaps were extracted through temperature dependence scans
- Non-linear behavior for both  $\nu_T = 1$  and  $\nu_T = 2$  at variable imbalanced and matched densities
- Valley [1], spin and Landau gaps should evolve linearly to 1<sup>st</sup> order w/ B in the absence of subband crossing



# $E_{2n}$ Results

Fan diagram generated by SP simulation: 4 energy sub-levels per LL since VS omitted

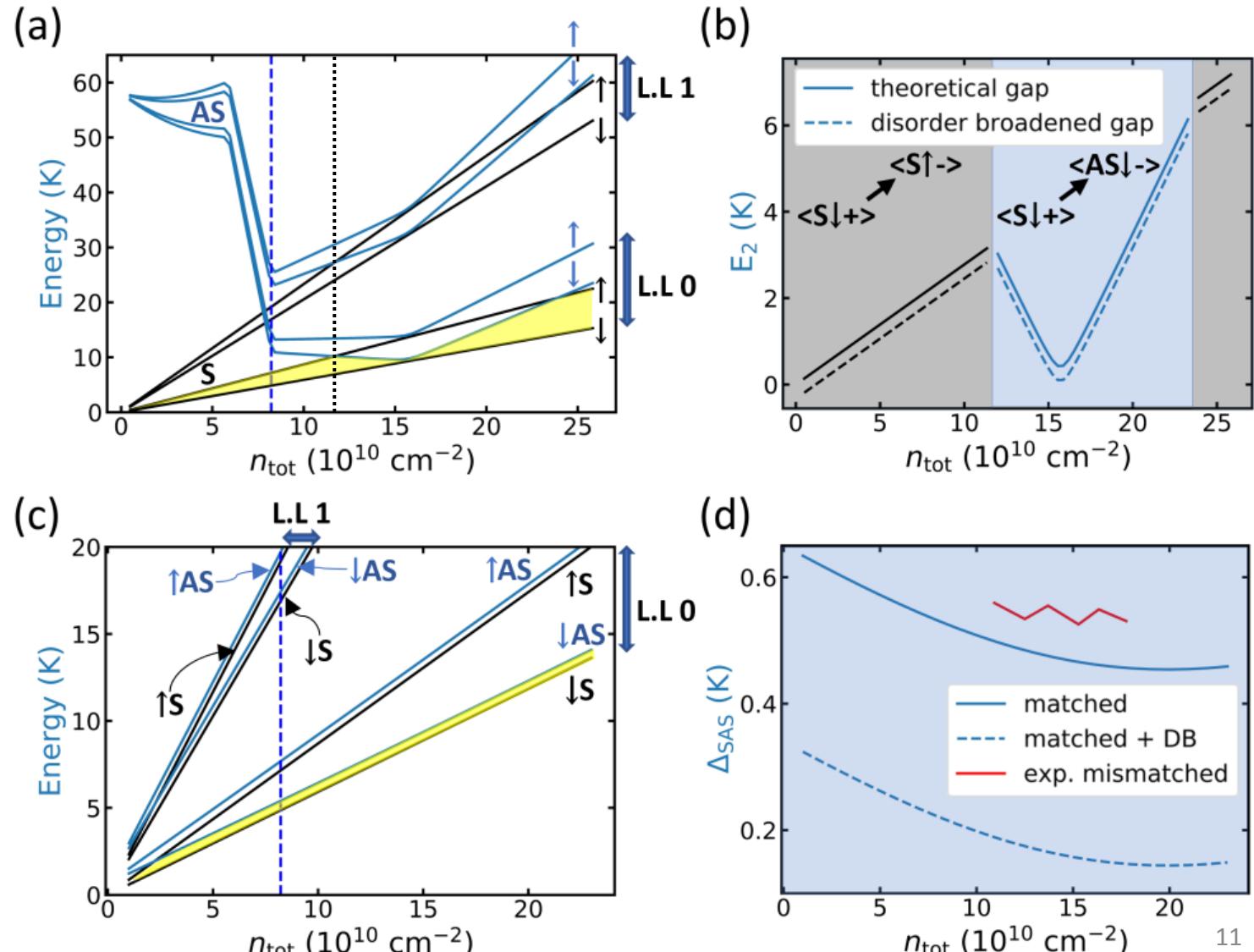
Variable Imbalanced

Densities:

$E_z$  and  $\Delta_{SAS}$

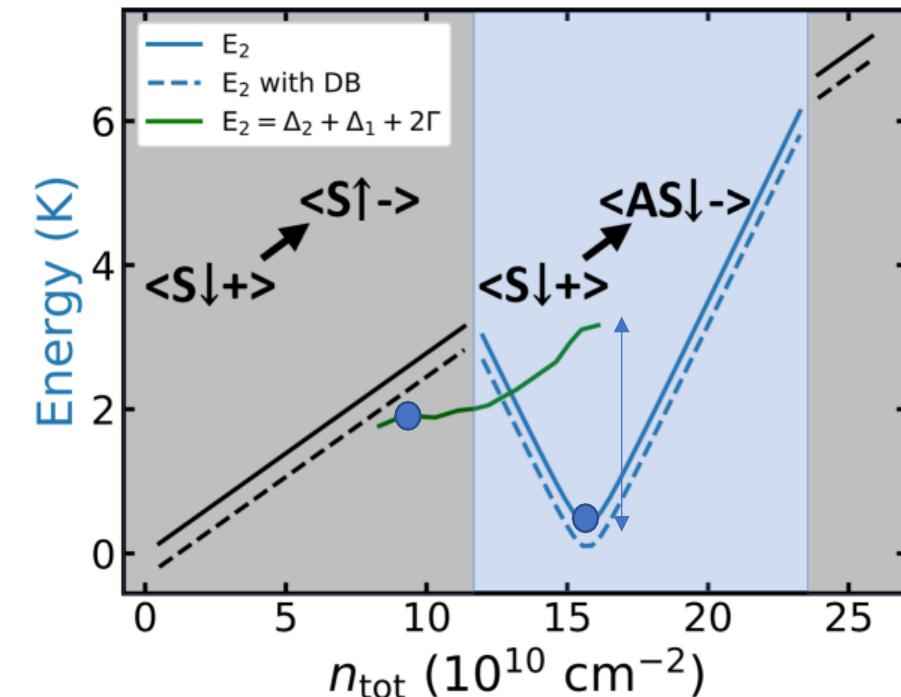
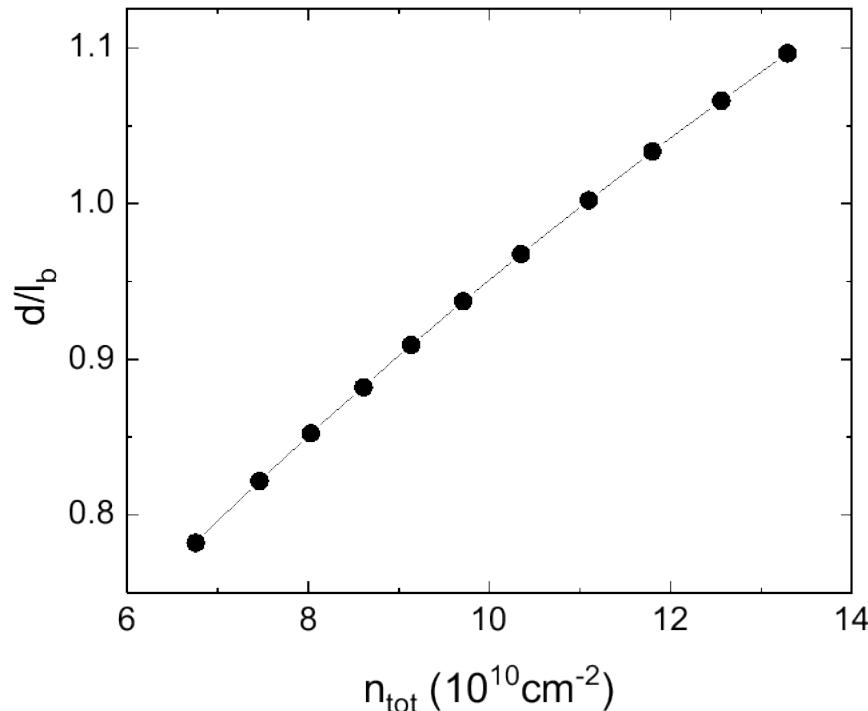
Matched Densities:

$\Delta_{SAS}$



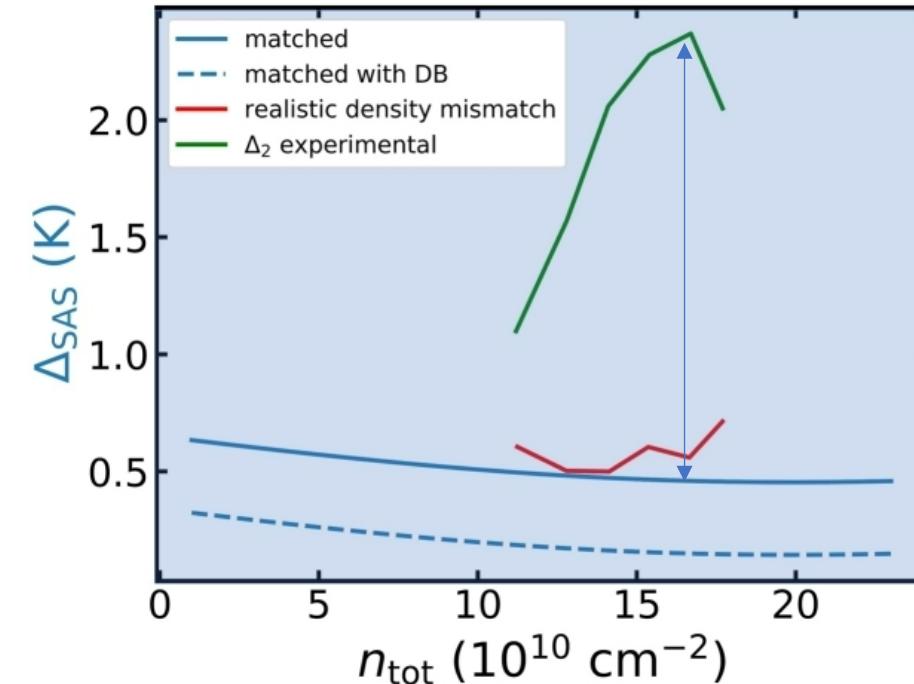
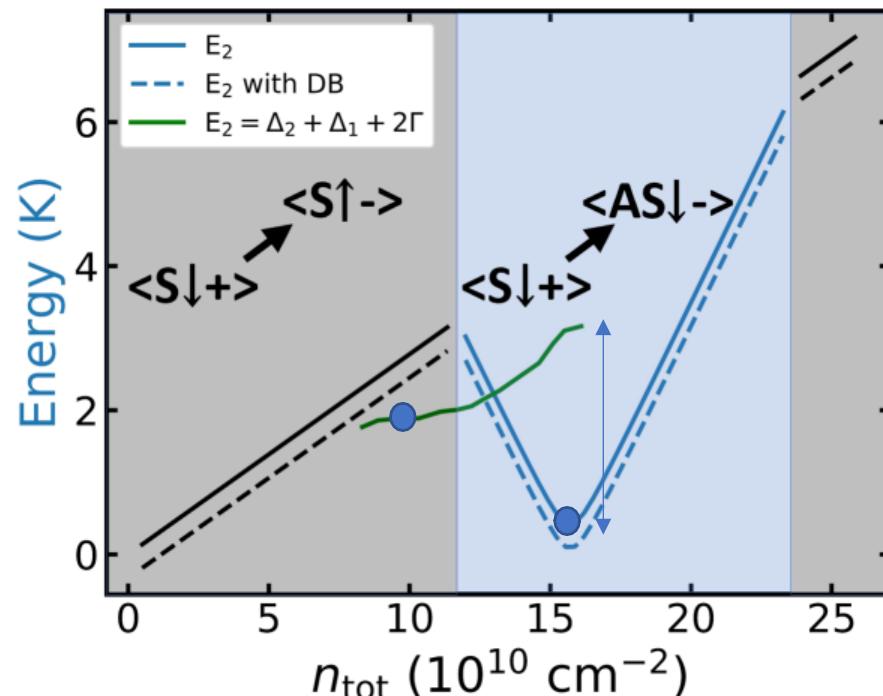
# Interpreting $v_T = 2$

- Interplay between spin splitting and interlayer effects,  $\Delta_{\text{SAS}}$  & SIC
- Device:  $d/\ell_b = [0.62-1.24]$  &  $e^2/\varepsilon\ell_b \approx 5 \times 10^{-4}$  indicating SIC is possible
- From theory,  $\Delta_2 = E_2 - E_1 - \Gamma = E_2 - \Delta_1 - 2\Gamma$
- $\Delta_1$  unknown at low  $n(B)$



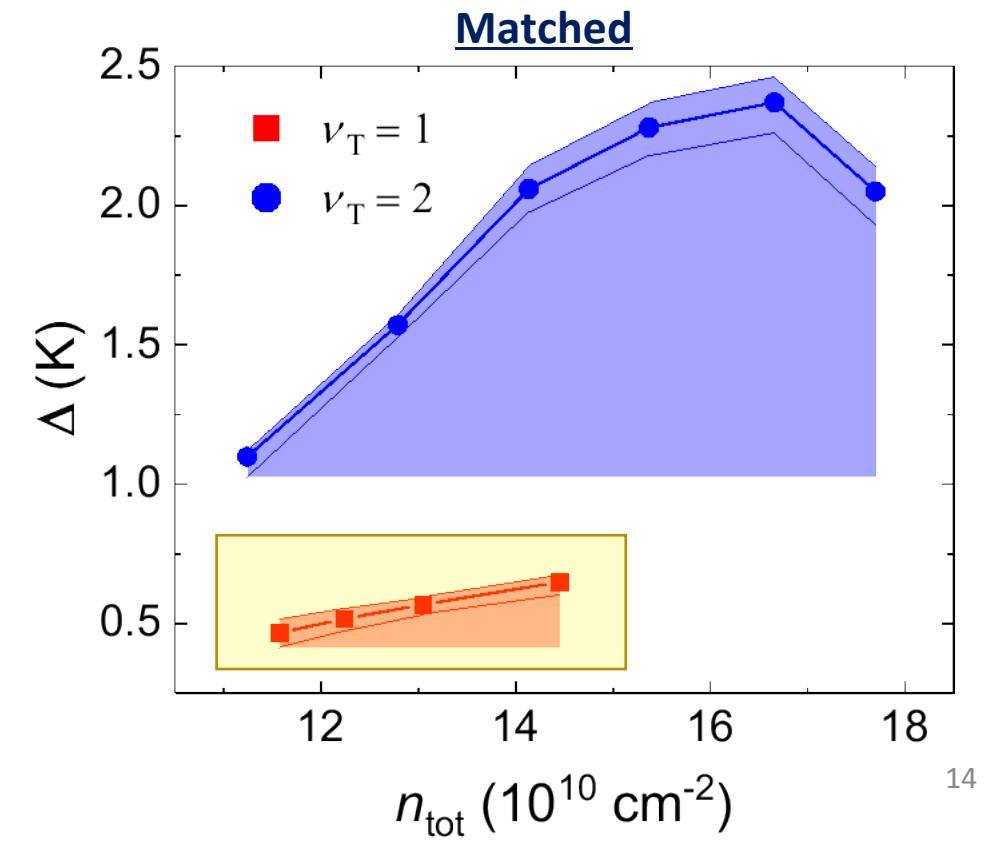
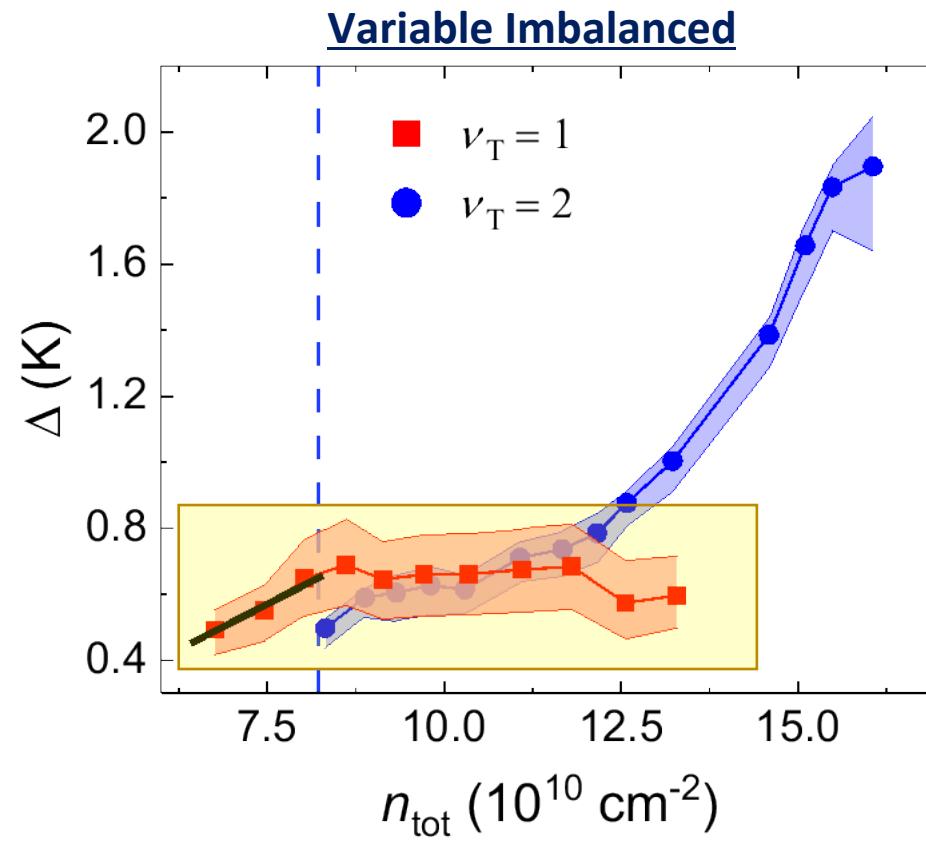
# Interpreting $v_T = 2$

- Neither  $\Delta_{\text{SAS}}$ , spin splitting, nor LL spacing alone reproduces  $\Delta_2$ .
- Strength of  $\Delta_2 \uparrow$ , induced by SIC:
  - $d/\ell_b \downarrow$
  - $\Delta v \uparrow$
  - $\Delta_{\text{SAS}} \downarrow$



# Valley Splitting & $v_T = 1$

- Single Layer: Disorder broadening,  $\Gamma \approx 0.327$  K and linear coefficient,  $c_B \approx 0.29$  K/T
  - $\Delta_v = E_v - \Gamma = c_B B - \Gamma$
- The bilayer dependence decreases and nearly flattens out (not understood)
- Si may exhibit large valley splitting at low B or spontaneous valley polarization



# Thank you for your attention!

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Nanotechnologies**

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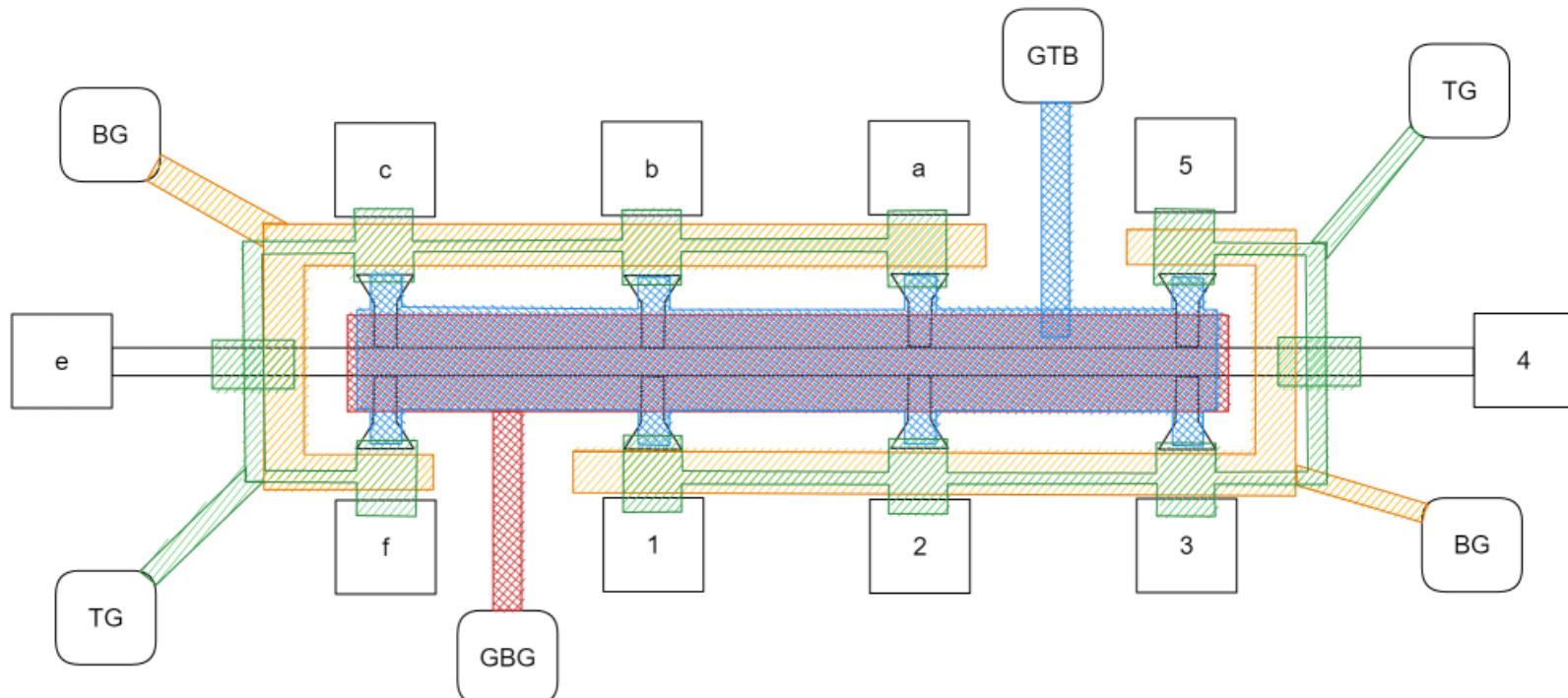
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# Summary

Dual gated undoped Si/SiGe bilayer

Single & Bilayer quantum Hall states at  $v_T = 1,2$

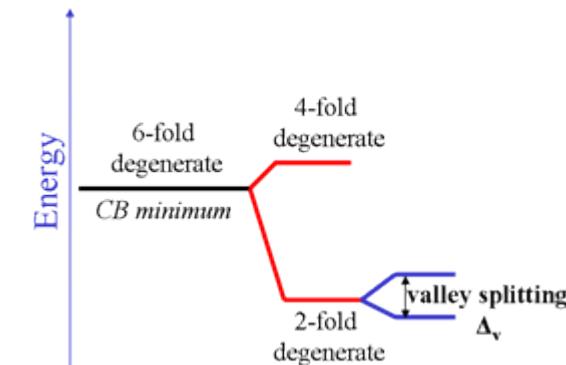
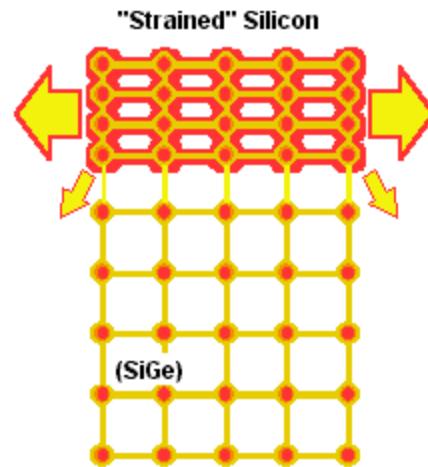
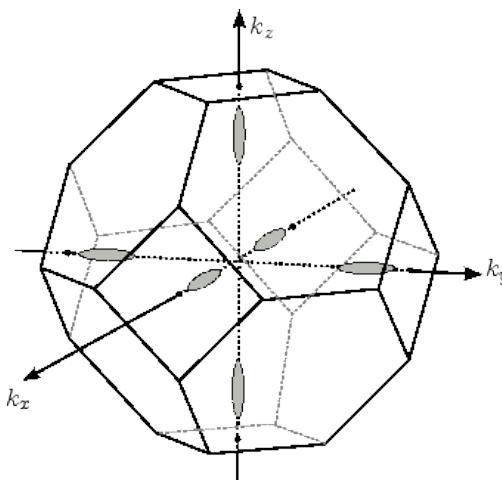
Evidence of Exciton Condensation warrants further investigation



Questions?

# Valley Splitting in Single Layers

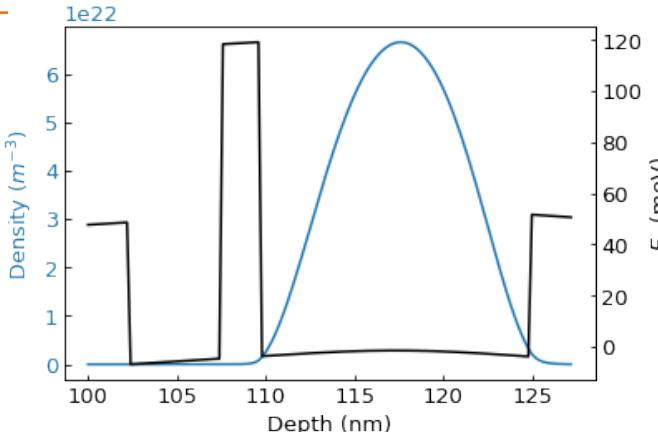
- In bulk Si, there is a 6-fold valley degeneracy
  - Tensile strain reduces it to 2-fold
  - Quantum confinement from the sharp quantum well interface lifts the degeneracy
- Atomic-scale disorder suppresses valley splitting
- Large valley splitting may be important for quantum computing



# Achieving Matched Density

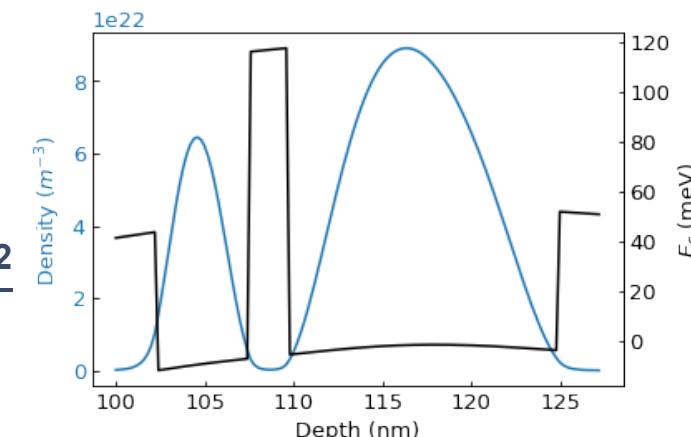
1. As  $V_{top}$  increased,  $n_{bot}$  increases until it saturates at  $n_{crossover}$
2.  $n_{bot}$  stays constant past  $n_{crossover}$  due to top layer screening
3. Now change  $V_{bot}$  ( $n_{top}^0$  unaffected by  $V_{bot}$  due to bottom layer screening)
  - $n_{top}^0 = n_{tot} - n_{crossover}$
4. Thus,  $n_{bot} = n_{tot} - n_{top}^0$

Matched density is achieved by collating the density dependence on the gates.



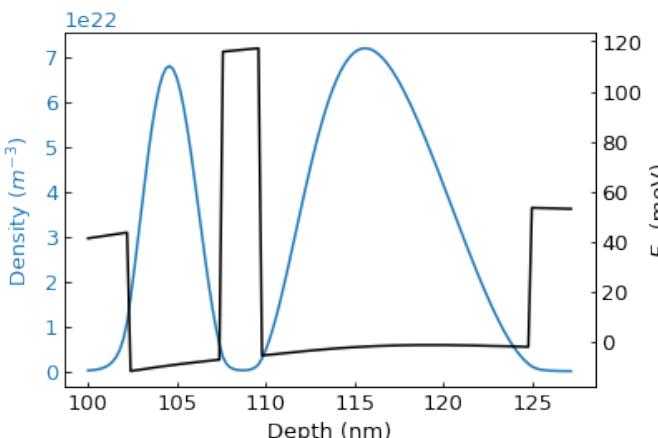
$$n_{top} = 2 \times 10^6 \text{ cm}^{-2}$$

$$n_{bot} = 6 \times 10^{10} \text{ cm}^{-2}$$



$$n_{top} = 2.1 \times 10^{10} \text{ cm}^{-2}$$

$$n_{bot} = 8.22 \times 10^{10} \text{ cm}^{-2}$$



$$n_{top} = 2.2 \times 10^{10} \text{ cm}^{-2}$$

$$n_{bot} = 6.12 \times 10^{10} \text{ cm}^{-2}$$

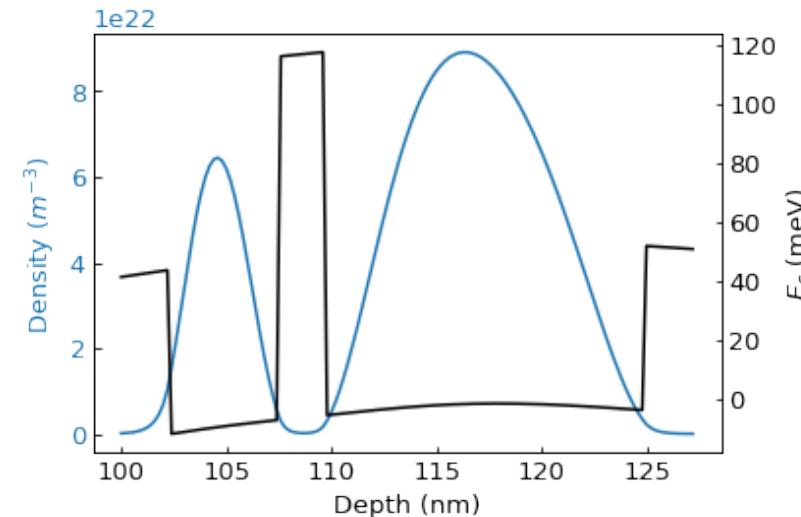
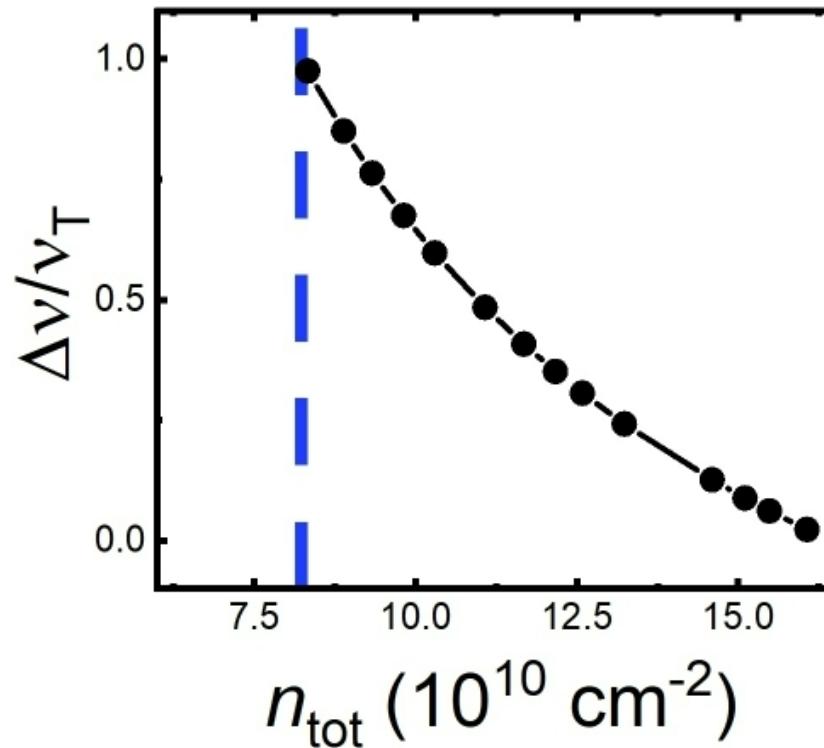
# Achieving Matched Density

- As  $V_{top}$  increased,  $n_{bot}$  increases until it saturates at  $n_{crossover}$
- $n_{bot}$  stays constant past  $n_{crossover}$  due to top layer screening (change  $V_{bot}$ )
- $n_{top}^0 = n_{tot} - n_{crossover}$  ( $n_{top}^0$  unaffected by  $V_{bot}$  due to bottom layer screening)
- Thus,  $n_{bot} = n_{tot} - n_{top}^0$
- Matched density is achieved by collating the density dependence on the gates.

$V_{top}$ (V)	$V_{bot}$ (V)	$n_{tot}$ ( $10^{10}$ cm $^{-2}$ )	$n_{top}$ ( $10^{10}$ cm $^{-2}$ )	$n_{bot}$ ( $10^{10}$ cm $^{-2}$ )	% Difference
0.62	-26.525	11.24	5.77	5.47	5.47
0.63	-18.976	12.79	6.43	6.36	1.22
0.64	-12.368	14.14	7.11	7.03	1.18
0.65	-6.375	15.37	7.84	7.53	4.04
0.66	-1.375	16.66	8.44	8.22	2.74
0.67	3.457	17.7	9.09	8.61	5.5
0.62*	-26.525*	11.57	5.77	5.8	0.53
0.625*	-22.613*	12.24	6.08	6.16	1.33
0.63*	-18.976*	13.05	6.43	6.62	2.76
0.64*	-12.368*	14.45	7.11	7.34	3.16

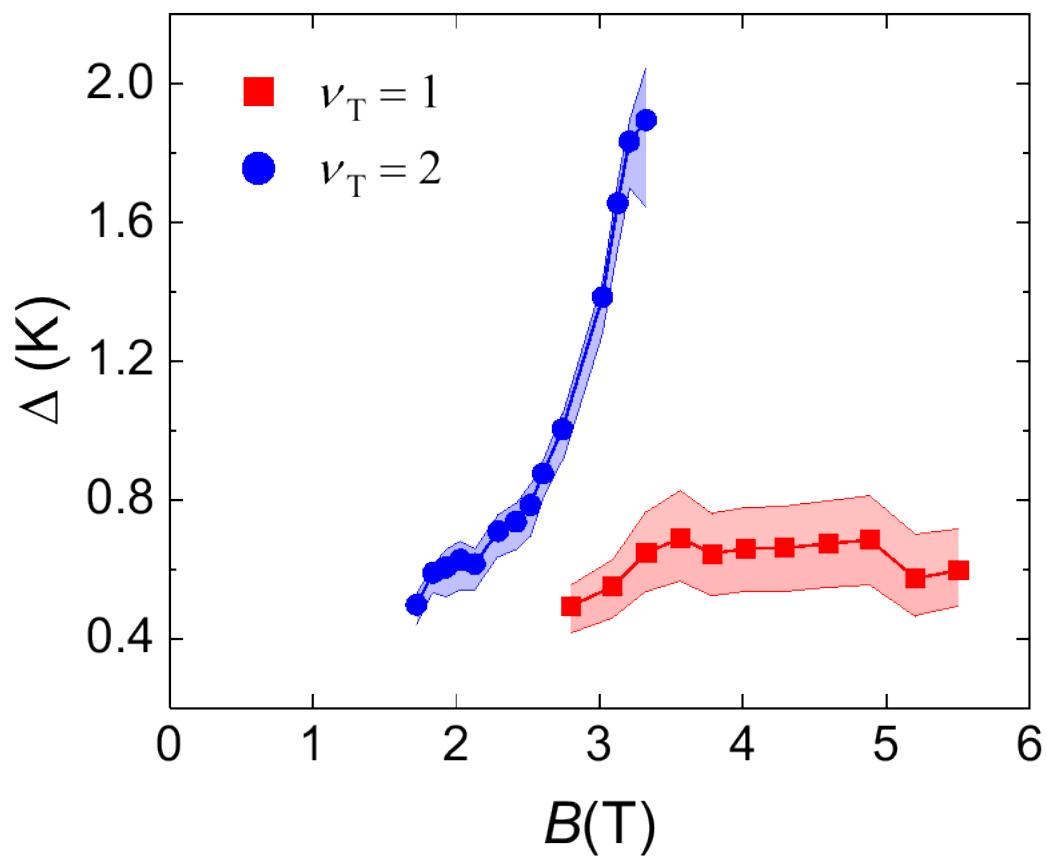
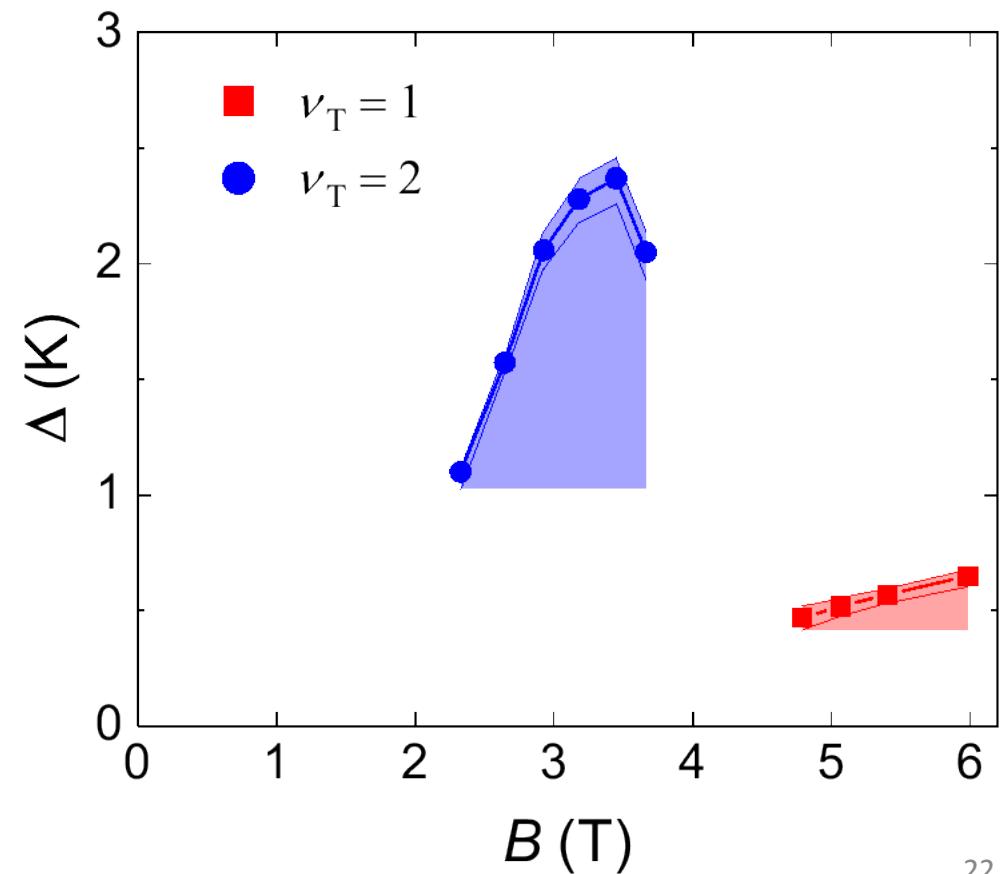
# Density Imbalance

- $v_T = n_T/(eB/h)$  &  $\Delta v = v_1 - v_2$
- $\Delta v/v_T = (v_1 - v_2)/2 \approx 0.5$  @  $n_{tot} = 11.07 \times 10^{10} \text{ cm}^{-2}$
- The onset of  $\Delta_2$ 's magnitude increase coincides w/  $\Delta v/v_T \approx 0.5$



$\Delta$  vs B

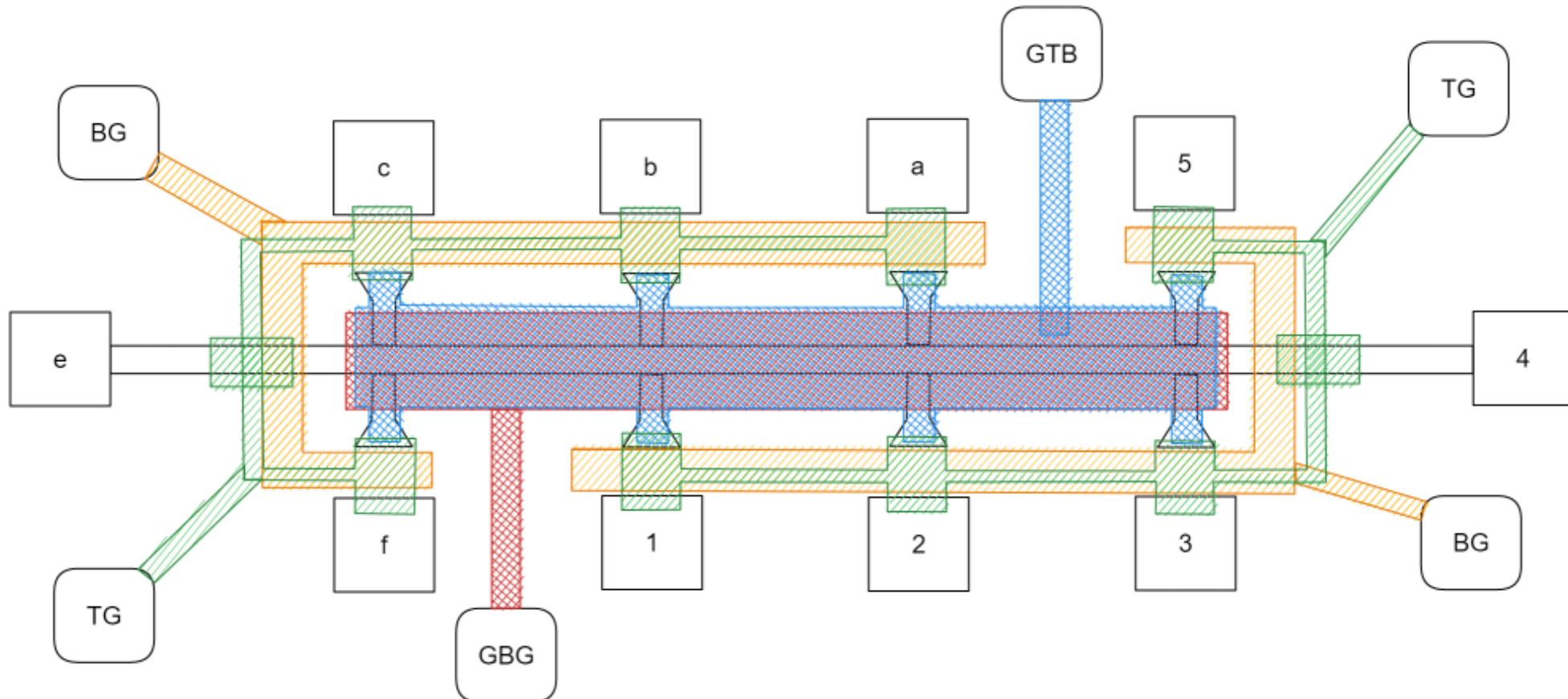
- $R_H = \rho_{xy} = R_K/v = h/e^2v$  (1980)  $[v_T = n_T/(eB/h)]$

Variable ImbalancedMatched

## FUTURE WORK

# Independent Contacts

- Designing a scheme to independently contact both layers simultaneously
- A combination of top/bottom accumulation gates + density gates
  - Global Top (Bot) Gate: Blue (Red) Contact Top (Bot) Gate: Green (Yellow)
- Unlocks tunneling conductance, Coulomb drag, and counterflow measurements



# NRF Fabrication

- Measuring Si/SiGe devices over a larger density range
  - Reduce the distance between the bottom QW and the bottom gate
  - Utilizing larger magnetic fields
- Fabricating Ge/SiGe bilayer devices at NRF
  - EBASE<sup>[1]</sup> technique (Tetramethylammonium hydroxide (TMAH))
  - Valley splitting dependence using a tilted magnetic field

